1 MeV, AMPERE CLASS ACCELERATOR R&D FOR ITER

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The present objective of the 1 MeV electrostatic accelerator R&D for the ITER NB system is acceleration of ampere class negative ion beams up to the beam energy of 1 MeV. However, there was no attempt of such high current and high energy acceleration in the past. The JAERI MeV accelerator has been designed extrapolating available vacuum insulation design guidelines (the clump theory and Paschen law) to Mega Volt and long vacuum gap. It was effective to reduce electric field concentration at triple junction by a large stress ring to prevent flashover along insulator surface. By the vacuum insulation technology above, the accelerator sustained 1 MV for 8,500 s continuously. Operating the KAMABOKO source with high power arc discharge (<40 kW), H⁻ ion beams of 146 A/m² (total ion current: 0.206 A) have been obtained stably at the beam energy of 836 keV (pulse length: ≥ 0.2 s). Strong enhancement of negative ion surface production has been attained by stopping vacuum leaks due to SF₆ permeation through Viton and O ring damages by backstream ions, followed by increase of the H⁻ ion current density toward 200 A/m² without saturation. The paper reports recent progress of the accelerator development at JAERI. Bremsstrahlung generation in the accelerator is also estimated from EGS4 analysis, and then discussion on the breakdown possibility follows.

1. Introduction

The ITER NB system has been designed to inject 33 MW of D^0 beams from two NB systems at the beam energy of 1 MeV [1]. To fulfill the requirement, the ITER beam source (ion source and accelerator) generates 1 MeV, 40 A (ion current density: 200 A/m²) of D⁻ ion beams.

R&D on high current and high current density ion sources has been carried out at JAERI to realize the ITER NB system. The KAMABOKO negative ion source [2] demonstrated production of high current density (300 A/m^2) H⁻ ions at low operating pressure (0.3 Pa, at the beam energy of 50 keV) [3], which fulfilled the ITER requirement. In addition, uniformity issue of large negative ion sources has been tackled extensively, under collaboration with universities in Japan. The studies revealed that 1) the uniformity of large negative ion beam is degraded by local destruction of the ions with fast electrons penetrating magnetic filter in pure volume operation [4]. 2) However, in Cesium seeded operation, negative ion current increases locally in the area where the electron temperature is high (Te > 1 eV). Thus it seems that the surface production of negative ions is strongly affected by local density of atomic hydrogen and/or proton [5].

As for the 1 MeV accelerator development, the key issues are, of course, to demonstrate acceleration of high current negative ion beams up to 1 MeV, though there was no attempt of such high current ion beam acceleration at the MeV range energy in the past. The objective of the present R&D is acceleration of ampere class negative ion beams up to the beam energy of 1 MeV. In 1998, nuclear analyses of the ITER NB system [6] clarified that the radiation environment around the beam source was too high to allow use of conventional insulation gas, such as SF₆, due to radiation induced conductivity (RIC) [7, 8]. And then, the design of the ITER beam source was changed so as to utilize vacuum insulation [9] instead of original gas insulation beam source. Considerable R&D has been carried out to achieve 1 MV high voltage insulation by vacuum [10]. As the result, the JAERI MeV accelerator succeeded in holding 1 MV for 8,500 s (\approx more than 2 hours) without any breakdown [11]. Since then, the experiments are in progress to accelerate high current H⁻ ion beams at the current density required for ITER (200 A/m²).

Difficulty of voltage holding in such high current accelerator has been pointed out due to irradiation of insulation materials by Bremsstrahlung, followed by photoelectron production in the insulator and breakdowns [12]. The present paper reports recent progress of the MeV level H⁻ ion beam acceleration together with an estimate on Bremsstrahlung generation in the

accelerator, followed by discussion of possible high voltage breakdown due to the photoelectron effect.

2. MeV accelerator

Figure 1 shows a picture of the "MeV test facility [13]" constructed in 1994 at JAERI to carry out the R&D of the 1 MeV, 1 A class negative ion accelerator. The high voltage power supply is a conventional Cockroft Walton type, as an extension of electron beam irradiation devices widely utilized in industries, for example, for rubber and polythin production. The power supply and the accelerator are contained in gas tanks, since the 1 MV high voltage is insulated by SF_6 insulation gas of 6 bar during operation. The gas tanks are located in underground pit of which wall and ceiling are made of $0.5 \sim 1$ m thick concrete to shield Bremsstrahrung generated upon electron beam acceleration.

In the beam source design of the ITER NB system, the accelerator is installed inside vacuum vessel, and the HV bushing mounted on the vessel, above the accelerator, forms a vacuum boundary. In the JAERI MeV accelerator, as shown in Fig. 2, the insulator column forms the vacuum boundary against the SF_6 insulation gas in the tank, simulating the HV bushing of the ITER design. The insulator column (1.9 m high in total for 1 MV insulation) consists of a stack of 5 FRP rings made of fiber-reinforced epoxy, each 1.8 m diameter and 0.33 m in height. The accelerator main structure (assembly of acceleration grids and their support structure) is inserted in vacuum inside the insulator column, utilizing the insulator column as the HV bushing.

A cross sectional view of the accelerator is shown in Fig. 3. There is a vacuum gap of 50 mm wide all around between the insulator column and the accelerator main structure. The acceleration grid support structures are suspended from the flange at top of the accelerator (-1 MV potential) via. several post insulators (made of Al₂O₃ ceramic), and only the parts connecting between the accelerator and the insulator column are current feedthroughs (stainless steel) of 10 mm dia. Thus the accelerator main structure is isolated from the insulator column, and immersed in vacuum to simulate the ITER vacuum insulated beam source.

In conventional accelerators of universities and industries, the clump theory [14], in which the sustainable voltage is proportional to square root of vacuum insulation distance, is applied as the insulation design guideline. By inserting many gradient grids to reduce voltage differences in between, gap length is reduced for compact design of the accelerator. Moreover the direct line of sight from the high voltage to the ground potential is limited only through apertures for the beam. The multigrid concept is also effective to prevent discharge (breakdown) occurred in one vacuum gap to propagate to others. On the other hand, the design of the JAERI MeV accelerator allows direct line of sight from -1 MV potential to the ground through the vacuum gap of 50 mm wide. Of course, the clump theory has also been taken into account as the vacuum insulation guideline in the MeV accelerator, however, the voltage insulated in vacuum gaps are much higher (200 kV ~ 1 MV), and subsequently, the gaps are longer than conventional accelerators.

As shown in Fig. 2, the KAMABOKO negative ion source is mounted directly on the accelerator without LEBT (low energy beam transport). This is possible since the negative ions do not form any molecular ions, and therefore, the ions extracted from the source are directly injected in the accelerator without mass separation. Since the gas fed in the source is pumped through the accelerator, the gas pressure in the accelerator increases during operation. The pressure estimated by a Monte Carlo analysis [15] ranges $0.02 \sim 0.1$ Pa in the ITER accelerator, which is high enough to cause glow (gas) discharge in the accelerator. Thus in addition to the clump theory for vacuum arc discharge, the Paschen law for the glow discharge has been considered in the insulation design of the MeV accelerator.

However, the MeV accelerator has been troubled with the high voltage insulation for long years. The breakdowns were characterized by X-ray emission and much amount of hydrocarbon outgassing, followed by the breakdown. By a careful observation of the interior of the MeV accelerator, many breakdown traces were found along inner surface (vacuum side) of the FRP rings. Moreover, it was also found that epoxy (soften at the temperature more than 100°C) in FRP melt and spilled along the surface. Both damages started at the triple junction where the interface of FRP insulator (dielectric), metal flange and vacuum. And hence, it was suspected that something like microdischarge occurred at the triple junction increases the temperature of the FRP, followed by both outgas and the local discharge to trigger a flashover along the insulator surface. In the original MeV accelerator, the electric field strength at the triple junction was designed so as to be 3 kV/mm, which is not so high comparing with that in conventional accelerators. However, in the case of FRP insulator rather than other ceramic, glass or porcelain ones, the electric field strength should be lowered further to prevent the outgassing following to the microdischarge. The MeV accelerator voltage holding capability was drastically improved by installing large stress rings in negative side of the FRP rings to lower the electric concentration to be as high as 1 kV/mm. By the vacuum insulation technology above, the accelerator sustained 1 MV for 8,500 s continuously [11].

The negative ions produced in the KAMABOKO negative ion source is extracted through 9 apertures (each 14 mm in diameter) drilled in 3 x 3 lattice pattern in the plasma grid (PLG, first grid illuminated by the source plasma). The extraction grid (EXG, second grid) has small permanent magnets embedded between the aperture rows for suppression of co-extracted electrons [16]. The accelerator has 4 intermediate girds (A1G \sim A4G) at every 200 kV potential difference, and grounded grid (GRG). The beamlets extracted are accelerated electrostatically through the apertures each of which is aligned with respect to corresponding apertures in the PLG and EXG. The grid spacing becomes progressively shorter at each downstream gap. Thus the electric field increases at each gap, and each aperture forms a convergent electrostatic lens counteracting the space charge expansion of the beamlets.

The beam current was measured by an inertia cooled calorimeter located downstream of the GRG in vacuum chamber in short pulse (≥ 0.2 s) operation. The bottom of the vacuum chamber is a beam dump consisting of an array of swirl tubes at the incident angle of 60°, of which allowable heat load is 80 MW/m², corresponding to 0.8 MeV 140 A/m² H⁻ ion beam at the divergence angle of 7 mrad.

3. Progress of MeV level H⁻ ion beams

The present experiment is in progress to accelerate the H⁻ ion beams of high current density, toward the ITER requirement of 200 A/m², up to 1 MeV. Parameters of the H⁻ ion beams accelerated to MeV range energy are summarized in Table 1. The H⁻ beams of 18 A/m² (total ion current of 70 mA) were accelerated up to 1 MeV for 1 s in pure volume operation. At present, the ion source is running under Cesium seeded operation to enhance the surface process of negative ion production. So far, H⁻ ion beams of 836 keV and 146 A/m² (total ion current: 0.206 A) have been obtained, and such high current (accelerator power supply current ~ 200 mA including electrons) beams are stably obtained several tens shots (pulse length \geq 0.2 s) stably even under the cesiated operation of the source.

The beam current as a function of the extraction voltage is shown in Fig. 4, for all the beam shots obtained in the experimental campaign in April 2005. Note that the beams were accelerated stably in wide operation window at under perveance conditions. The accelerated beam current does not show clear saturation tendency, suggesting that enough amount of H⁻ ions are produced in the source. Since the KAMABOKO source itself has already achieved $300 \text{ A/m}^2 \text{ H}^-$ ion productions, further increase of the current/current density is expected

toward the ITER required current density.

Figure 5 shows a picture of a low energy beam footprint taken by an infrared camera at 3 m downstream from the grounded grid. The beamlets extracted from 3 x 3 aperture array are clearly identified at a perveance-matched condition for the low current beam at 200 keV in pure volume operation. A picture of the high-energy beam taken at 2 m downstream is shown in Fig. 6. As is shown in the figure, the beamlets are distinguished for the H⁻ ion beam of 146 A/m^2 even after the acceleration to 836 keV.

Recent increase of the beam current density has been achieved after stopping following vacuum leakages:

1) SF₆ leaks through Viton O-rings

The gas is fed in the ion source continuously during operation when the high voltage of more than 700 kV is applied to the accelerator, so that the accelerator sustain the voltage at the pressure in which the best voltage holding capability is achieved. Thus solenoid valves in the gas feed line are kept open during the high-energy beam experiment. The valve temperature increased to about 100°C during the operation, and the Viton O-rings used at interface to the inlet/outlet gas pipes started to allow SF₆ permeation from outside of the valves to the gas line, followed by contamination of the Cs inside the ion source. It was not easy to imagine the permeation of huge SF₆ molecules through popular Viton O-ring, however, a data sheet [17] noticed the possibility of SF₆ permeation through fluorocarbon rubber, such as Viton, if the fluorine content was less. The o-rings in the solenoid valves were all removed and the interfaces were welded.

2) O-ring damage due to backstream ions

The KAMABOKO negative ion source has a port on the top, on the extension of the beam center axis, normally closed by a stainless steel plug with piston O-ring seal. Long pulse experiment of the source at Cadarache reported the port plug melt by backstream ions, followed by air leak due to damage of the O-ring [18]. As the current density and the beam energy of the beam was increased, the same air leak occurred in the KAMABOKO source of the MeV accelerator. The leak was stopped replacing the port and the plug with a flange made of brass closely attached to the water-cooled source body. Although the heat load on the source due to the backstream ions were briefly estimated for the ITER beam source, and the MeV accelerator is running similar condition, further analyses of backstream ions seem to be necessary in detail.

Figure 7 shows the progress of the MeV accelerator R&D, by plotting the achieved beam current density as a function of the energy. After success in the 1 MV holding, the beam current density increased gradually, according to the source operation tuning such as Cs seeding condition and high power operations. Note that the beams obtained at present have a very high power density; i.e. 836 keV x 146 $A/m^2 = 122 MW/m^2$. This power density is more than twice higher than those of negative ion sources in existing NB systems [19, 20]. Thus the beam energy and current density of the JAERI MeV accelerator are approaching to the ITER relevant regime.

4. Bremsstrahrung and photoelectron generation

Bremsstrahrung is generated upon collision of energetic electrons on a copper target (accelerator grid or beam dump). The Bremsstahrung generation process was analyzed using EGS4 code [21] for electron cascade reaction in solid. Figure 8 and 9 shows the angular distribution of generated photons and their energy spectrum, respectively. The result shows the maximum number of photons generated in a case of 1 MeV electron incident is 0.0386 photon/electron Sr⁻¹ (per unit solid angle). Whilst the energy spectrum shows quick decrease of photons with the energy higher than 200 keV.

Figure 10 is the line attenuation coefficient of photons in Lead as a function of the photon energy [22]. As is well known, low energy photons are attenuated by photoelectron effect, MeV range photons by Compton scattering, and further high-energy photons by electron pair formation. For light elements, such as Carbon used in the FRP, the line attenuation coefficients were estimated considering the atomic number dependence, as shown in the figure in solid lines. Since the photoelectron effect has strong atomic number dependence, the attenuation by the photoelectron effect in light elements becomes weaker than Compton scattering even for the low energy photons of < 100 keV.

Here we estimate the photon density on the inner surface of FRP rings, assuming 1) electron current of 0.1 A (a typical electron current in the present experiment), 2) isotopic photon emission (0.0386 photon/electron Sr⁻¹) from center of the insulator column, and 3) at the photon energy of 100 keV. Then the photon density is estimated as follows on the FRP rings of 1.8 m diameter and 0.33 m high:

$$2.37 \times 10^{11} \text{ photon/cm}^2 \text{ s}$$
 (1)

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From Fig.10, taking the line attenuation coefficient for the photoelectron effect to be 1 x 10^{-4} /cm, the number of photons attenuated in the FRP ring (54 mm thick) is:

$$1.28 \times 10^8 \text{ photon/cm}^2 \text{ s}$$
 (2)

Here if we assume that the number of photons absorbed is the number of electrons generated in the insulation material, then the electron current flowed in a beam pulse is estimated to be 0.38 μ A. On the other hand, from the cataloged data on [23], surface and volume resistance of the FRP ring are 10¹¹ Ω and 10¹⁰ \sim 10¹⁴ Ω m, respectively. And hence, the dark current flowed In the FRP during the rated voltage of 200 kV/FRP ring would be

(surface current) $34 \,\mu A$ (3)

(volume current) $0.02 \sim 200 \,\mu A$ (4)

Thus the photoelectron current is 2 - 3 orders of magnitude smaller than the dark current flowed by the inherent conductivity of the insulation material.

In the estimation above, only the current by the primary photoelectrons was considered. In the reality, the electrons are energetic (<100 keV), and many secondary electrons are to be generated in the insulation material from the primary electron. However, the estimate above suggests that secondary electron emission coefficient of 100-1000 is still acceptable, considering the dark current in the FRP.

In the case of ITER accelerator with much higher current, the possibility of breakdown by the photoelectron effect is not clear at present. However, from the discussion above, it could be suppressed by additional shield around the accelerator or near the HV bushing, since low energy X-ray is attenuated to 1/10 only by a 1 cm thick lead.

5. Conclusion and future issue

The vacuum insulation technologies have been established for the MeV accelerator. 1 MV stable holding was achieve by reducing the electric field concentration at the triple junction. The beam acceleration is in progress toward the ITER relevant beams of the current density

of 200 A/m² at 1 MeV. At present, we have obtained 146 A/m² (206 mA) H⁻ ion beams at 836 keV (pulse length: 0.2 s). The beam power density (energy x current density) is more than twice higher than the beams of the existing NB systems. For further increase of the beam power and pulse length, a new beam dump has already been prepared for the heat load corresponding to 1 MeV 200 A/m² beam. The beam optics study and demonstration of long pulse operation are to be carried out after replacement of the beam dump. Stability of the accelerator in long pulse operation might reveal the behavior of the breakdowns due to the photoelectron effect. The EGS will again be utilized for the analyses of the photoelectron and secondary electron behavior in the insulator.

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	Ion source operation conditions	
Parameters	Pure volume (without Cs)	Cs seeded
Source operating pressure (Pa)	0.3	
Number of extraction apertures	25 (5 x 5 lattice pattern)	9 (3 x 3)
Beam energy (keV)	1000	836
H^{-} Ion current (I _H -, mA)	70	206
H^{-} Ion current density (A/m ²)	18	146
Power supply drain current (I _{acc} , mA)	143	265
Pulse length (s)	1.0	0.2

Table 1. A summary of 1 MeV, 100 mA level H⁻ Ion beam acceleration.



Fig. 1 A picture of the "MeV test facility" at JAERI.

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Fig. 2 The JAERI MeV accelerator. The insulator column forms the vacuum boundary against the SF_6 insulation gas in the tank.

IAEA Tech. Meeting at Padova, May 9-11 '05









Fig. 5 An infrared image of the beamlet footprint (beam energy: 200 keV).



Fig. 6 A picture of the 800 keV H⁻ ion beam taken at 2 m downstream.



Fig. 7 The progress of the MeV accelerator R&D, by plotting the achieved beam current density as a function of the energy.



Fig. 8 A result of the Bremsstrahrung analysis by EGS4code, phton generation angular distribution.



Fig. 9 A result of the Bremsstrahrung analysis by EGS4code, energy spectrum.



Fig. 10 The line attenuation coefficient of photons in solid.